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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **Yoshihisa IBA et al.**

Group Art Unit: **2813**

Application Number: **10/774,496**

Examiner: **Jack S.J. Chen**

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For: **METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE**

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AMENDMENT UNDER 37 C.F.R. § 1.111

Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

September 5, 2006

Sir:

This paper is filed in response to the Office Action dated June 5, 2006 in the above-identified patent application. Applicant respectfully request reconsideration and withdrawal of the rejection in view of the following amendments and remarks.

Amendments to the Specification begin on page 2.

Amendments to the Claims begin on page 3.

Remarks begin on page 9.